

<b>Notice of References Cited</b>	Application/Control No. 10/779,736	Applicant(s)/Patent Under Reexamination KUO, CHEN LUNG	
	Examiner Wen-Ying P. Chen	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,671,025	12-2003	Ikeda et al.	349/156
	B	US-2001/0026347	10-2001	Sawasaki et al.	349/156
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

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